

#12/c  
10  
PATENT 9/18/02



Docket No.: 52352-372

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of :  
Jeffrey A. SHIELDS, et al. :  
Serial No.: 09/498,336 : Group Art Unit: 1765  
Filed: February 04, 2000 : Examiner: V. Perez-Ramos  
For: CF4 + H2O PLASMA ASHING FOR REDUCTION OF CONTACT/VIA  
RESISTANCE

**AMENDMENT**

**RECEIVED**  
SEP 18 2002  
**TC 1700**

Commissioner for Patents  
Washington, DC 20231

Sir:

The following Amendment and Remarks are submitted in response to the Office  
Action dated June 16, 2002.

**IN THE SPECIFICATION:**

Page 1, please amend the first full paragraph under the caption "RELATED  
APPLCIATION" as follows:

This application contains subject matter similar to subject matter disclosed in  
copending U.S. Patent Application Serial No. [ ] 09/498,335 filed on  
February 4, 2000 [ ] (Our Docket No. 52352-371)].